

## **Finance Program Overview** (Subject to updates and changes)

	DAY 1: December 2, 2025
8:00am – 8:45am	Registration & Refreshment
8:45am	Attendees to be seated
Venue	Resort World West Ballroom at Basement 2
9:00am - 9:10am	Welcome Speech: Dr Eric Phua, EPTC 2025 General Chair
9:10am - 9:20am	Opening Speech: Prof Jeffery Suhling (EPS President-Elect)
9:20am - 10:05am	Keynote 1: Dr Radha Nagaranjan, SVP/CTO, Marvell  Scaling Al Infrastructure with Advanced Optical Interconnects
10:05am - 10:30am	25min Coffee Break @ West Ballroom Foyer
10:30am - 11:15am	Keynote 2: Audrey Charles, SVP, Lam Research Interconnect Horizons: Wafer and Panel Innovation and Industry Partnerships to Unlock Al's Next Step
11:15am - 12:15pm	Panel Session: Advances and Challenges in Metrology and Test for Heterogeneous Integration Moderator: Pax Wang, UMC Panelist: Dr James S. Papanu (TEL), Dr Sia Choon Beng (FormFactor), Bhupi Kumar (KLA-Tencor)
12:15pm - 12:35pm	Technology Solution Presentation: by Lam Research (Diamond Sponsor)
Venue	West Ballroom Foyer
12:35pm - 1:40pm	Lunch @ West Ballroom 1 and Foyer
	Exhibition Hall Opens (LEO 1-4 Function Room at Level 1)
Venue	Resort Worlds West Ballroom at Basement 2
1:40pm - 2:25pm	Keynote 3: Pax Wang, TD Director, UMC  Rewiring Edge Al System Efficiency with Advanced Packaging
2:25pm - 2:40pm	Technology Solution Presentation: by Applied Materials (Platinum Sponsor)
2:40pm - 3:25pm	Keynote 4: Prof. Harald Kuhn, Director, Fraunhofer Institute of Electronic Nano Systems ENAS  Driving Innovation Through Hetero-Integration: Technologies, Challenges and Future Directions
3:25pm - 3:50pm	25min Coffee Break @ West Ballroom Foyer
3:45pm - 4:00pm	Technology Solution Presentation: by KLA-Tencor (Platinum Sponsor)
4:00pm - 5:00pm	Panel Session: Co-Packaged Optics: The Next Inflection Point for Advanced Packaging Moderator: Dr Surya Bhattacharya (IME) Panelist: Dr Torsten Wipiejewski (Huawei), Cindy Palar (Celestial AI), Dr Patrick Lo (Advanced Micro Foundry)
5:00pm - 5:45pm	Welcome Reception @ West Ballroom Foyer
6:30pm - 8:00pm	VIP Dinner @ Tangerine, Equarius Hotel (by invitation only)

	DAY 2: December 3, 2025					
Venue	AQUARIUS 2-3	AQUARIUS 4	GEMINI 1	GEMINI 2	PISCES 1	PISCES 2
	PDC1	PDC2	PDC3	PDC4	PDC5	PDC6
08:30am - 10:00am	Advanced Packaging for Chiplets, Heterogenous Integration and CPO <b>Dr John Lau (Unimicron)</b>	Photonic Components and Packaging Technologies for Data Center, Communications, Sensing & Displays Dr Torsten Wipiejewski (Huawei)	Advanced Packaging for MEMS and Sensors <b>Dr Horst Theuss (Infineon)</b>	Current and Future Challenges and Solutions in AI & HPC System and Thermal Management Dr Gamal Refai-Ahmed (AMD)	Overview of Characterization Techniques for 3D HI Circuit Packaging Prof Ali Shakouri (Purdue University)	Design-on Simulation Technology for Reliability Prediction of AP <b>Prof K.N. Chiang</b> (National Tsing Hua University)
10:00am - 10:30am			30min Coffee Break outsic	de Exhibition Hall (LEO 1-4)		
10:30am - 12:00pm	PDC1 (con't)	PDC2 (con't)	PDC3 (con't)	PDC4 (con't)	PDC5 (con't)	PDC6 (con't)
12:00pm - 1:15pm			EPS Luncheon @ I	PISCES 2 to Virgo 3		
1:15pm - 2:25pm		Tech	nology Innovation Showcase - Ses	ssion 1 (70 min)   Quiz & Prizes Inc	luded	
Venue	AQUARIUS 3	AQUARIUS 4	GEMINI 1	GEMINI 2	PISCES 1	PISCES 2
2:25pm - 3:10pm	Materials and Processing 1	TSV/Wafer Level Packaging 1	Mechanical Simulation & Characterization 1	Interconnection Technologies 1	Advanced Packaging 1	Emerging Technologies
Session Chair	Alvin Lee, Brewer Science	Sungdong KIM, SeoulTech	Jeff Suhling, University of Auburn	Ksenija Varga, EV Group	Karsten Meier, TU Dresden	Christian Tschoban, IZM
2:25pm - 2:40pm	P372 (111)-Oriented Nanotwinned/ Nanograined Bilayer Cu for Post-Q- time Low Temperature Cu-Cu Bonding  Peng, Gangqiang City University of Hong Kong,		P317 Toward lifetime prediction under variable load conditions in power electronics  Horn, Tobias Daniel  Micro Materials Center, Fraunhofer	P266 Surface Treatment for Wafer Bonding using Atmospheric Vapor Plasma Technology  Lee, Seokjun  Samsung Electronics, Korea	P170 Development of Embedded Bridge Die interposer Using FO Packaging for HI of NPUs and HBMs  Kim, Jay nepes, Korea	P326 3D Surface Ion Trap Process Development for Quantum Applications  Li, Hongyu Institute of Microelectronics,
2:40pm – 2:55pm	Hong Kong P167 Enhancing Wafer Bonding Strength via Surface and Dielectric Modification Using Plasma Activation Process  Park, Jaehyung Samsung Electronics, Korea	P319 RDL-first FOWLP Development for III-V Semiconductor Chips in RF Applications  Ho, Soon Wee David  Institute of Microelectronics, A*STAR, Singapore	ENAS, Chemnitz, Germany  P255 Board level solder reliability and package stress for TSiCV  UBM/bump IC package design  Mandal, Rathin  Institute of Microelectronics, A*STAR, Singapore	P185 Study of Extremely Low Temperature Organic Hybrid Bonding with Grain Engineered Cu Maruyama, Yoshiki Resonac Corporation	P287 HI of High-Performance Compute, Memory and Photonic Engine Chiplets on Large Molded Interposer package Chai, Tai Chong Institute of Microelectronics, A*STAR, Singapore	A*STAR, Singapore P161 2.5D Cryogenic Packaging for Advanced Quantum Processors  Jaafar, Horhanani  Institute of Microelectronics, A*STAR, Singapore
2:55pm – 3:10pm	P356 Analysis of SiO <sub>2</sub> surface chemistry by quasi-in situ XPS during N <sub>2</sub> plasma activation for SiO <sub>2</sub> /SiO <sub>2</sub> bonding  Jin, Renxi  Institute of Microelectronics of the Chinese Academy of Sciences, China	P302 Mitigating Connected PAD Corrosion in Hybrid Bonding Chew, Soon Aik IMEC, Belgium	P138 Design of Wire Bonding Schemes for Reliability of CQFP Packages under Vibration Test  Ma, Yiyi  STMicroelectronics, Singapore	P355 Bond line thickness stability of Cu sintering for automotive power module packaging  Kim, Byeongchan  Korea Institute of Industrial Technology, Korea	P199 Ultra-low-TTV Glass Carrier and Temporary Bonding Method to Enable Wafer Ultra-thinning  Chang, Ya Huei  Corning incorporated	P208 Wafer-level Processes for the Manufacturing of Encapsulated Flexible Polymer-Based Implants Costina, Andrei Fraunhofer IZM

## **DAY 2: December 3, 2025 (con't)**

3:10pm - 4:40pm	Interactive Presentation 1 (Poster), Exhibition and Coffee Break outside Exhibition Hall (LEO 1-4)					
Venue	AQUARIUS 3	AQUARIUS 4	GEMINI 1	GEMINI 2	PISCES 1	PISCES 2
4:40pm -5:40pm	Materials and Processing 2	Thermal Management and Characterization 1	Mechanical Simulation & Characterization 2	Interconnection Technologies 2	Advanced Packaging 2	Assembly and Manufacturing Technology 1
Session Chair	Kim Shyong Siow, UKM	Kazuyoshi FUSHINOBU, Tokyo Institute of Technology	Seungbae Park, Binghamton University	James Papanu, TEL	RHEE Minwoo, SAMSUNG	Haruichi Kanaya, Kyushu University
4:40pm – 4:55pm	P343 Chip Stacking: Impact of Chip Spacing in C2W hybrid bonding on Temporary Bonding and Debonding		P332 Prediction of Void-induced Crack Propagation within Underfill using the Meshless Material Point Method	P188 A Novel Interface Characterization Technique for Hybrid Bonding Process Optimization	P354 Innovation and Efficiency in 3D Packaging Enabled by Optimized Integration Processes	P201 High-Density Interconnect RDL-FPC Hybrid Substrate for Compact SiP Packaging
	Sharma, Jaibir	Micron Technology Operations India	de Jong, Sjoerd Douwe Medard	Sameshima, Junichiro	Varga, Ksenija	Li, Jeng-Ting
	Institute of Microelectronics, A*STAR, Singapore	LLP	Delft University of Technology	Toray Research Center, Inc., Japan	EV Group, Austria	Unimicron Technology Corp., Taiwan
4:55pm – 5:10pm	P382 Water Vapor Permeation in Low-Temperature Processable Polyimide Materials for Reliable Polymer HB Nomura, Kota	P223 CFD and Surrogate Model- Driven Optimization of Two-Phase Immersion Cooling Configurations  Jalali, Ramin  National Yang Ming Chiao Tung University		P174 Gas-Free & Nano TiO2-Coated Ag Bonding Wire for Replacing Au Wire Park, Soojae OxWires Co., Ltd., Korea	P275 Seamless Heterointegration of Components: Advancements in Fanout Technology and Thermal Solutions in SIP Gernhardt, Robert Fraunhofer IZM, Germany	P365 Novel UV-USP Laser Grooving and Plasma Dicing Separation Schemes for Next Generation Advanced Packaging Evertsen, Rogier ASMPT ALSI, The Netherlands
5:10pm – 5:25pm	P165 Novel TIM1 paste for Enhanced Thermal Management Liao, Yile Heraeus Materials Pte Ltd, Singapore	P153 Thermal Design and Power Dissipation of Advanced Package with Heterogenous Integration  Han, Yong Institute of Microelectronics, A*STAR, Singapore	P294 Optimization of Warpage and Mechanical Properties for Stacked SIP Package  Liu, Zhen  Changsha AnMuQuan Intelligent Technology Co., Ltd, China	P280 High-AR, Fine-Pitch Through- Mold Interconnect Fabrication for Heterogeneous Integration of HPC Chia, Lai Yee Institute of Microelectronics, A*STAR, Singapore	P102 A Packaging Structure for an Antenna-in-Package Module  Tain, Ra-Min Unimicron Technology Corporation, Taiwan	P173 Is Flash Lamp Annealing a Relevant Wafer Debonding Technique? Jedidi, Nader IMEC, Belgium
5:25pm – 5:40pm	P362 Applicability of Both-Sided Flash Lamp Annealing (FLA) Method on Heat Treatment Cu Plating Thin Film and Low Dielectric Resin Films  Yi, Dong Jae Graduate School of Engineering, Kanto Gakuin University	P142 PIV-Based Study of Heat Dissipation and Clogging phenomenon of TiO <sub>2</sub> Nanofluid in Microchannels  Li, Tieliang  Xidian University, China	P241 Electric-Thermal Coupled Transient Simulation for a Schottky Diode with Temperature Dependent Resistivity of Epitaxial Layer Yahaya, Khairul Ikhsan Nexperia Hong Kong	P144 Interfacial Reactions of Biln and SnBi Solders React with Cu Substrate  Wang, Yi-Wun  Tamkang University, Taiwan	P303 Using WGAN-Based Data Augmentation Machine Learning Algorithm for Estimating the Equivalent Material Properties  Su, Qinghua  National Tsing Hua University, Taiwan	P301 Cost efficient Infrared Laser debonding technology enabled by Si carrier reuse Chancerel, Francois IMEC, Belgium
5:40pm - 6:45pm	Sponsors/Exhibitors Appreciation and Networking Cocktail Session @ AQUARIUS 1 & 2					

			DAY 3: Dece	mber 4, 2025		
Venue	AQUARIUS 3	AQUARIUS 4	GEMINI 1	GEMINI 2	PISCES 1	PISCES 2
8:45am -10:45am	TSV/ Wafer Level Packaging 2	Smart Manufacturing and Equipment Technology 1	Mechanical Simulation & Characterization 3	Quality, Reliability & Failure Analysis 1	Advanced Packaging 3	Assembly and Manufacturing Technology 2
Session Chair	Peng Zhao, imec	Sachin Dangayach, AMAT	Chiang Kuo Ning, National Tsing Hua University	Xue Ming, Infineon	Toh Chin-Hock, Lam Research	Dongshun Bai, Brewer Science
8:45am – 9:00am		P242 Connectivity-Guided Feasibility Masking for Efficient Chiplet Placement in 2.5D Packaging via Reinforcement Learning Kundu, Partha Pratim Institute for Infocomm Research (I2R),	P177 Study on the Warpage Simulation and its Validation of Lidded FCBGA with Indium alloy TIM  Park, Yoonsoo	induced Corrosion on Al Bondpads and Wafer Fabrication Process Improvement  Hua, Younan WinTech Nano-Technology Services	P312 Characterization of PVD Seed Layer Contact Resistance in 2.0 to 20.0 µm Vias Carazzetti, Patrik Evatec AG,	P273 Selective Post-Soldering Volume Adjustment for Improved Co-Planarity of C4 Bump Interfaces Fettke, Matthias PacTech GmbH,
9:00am – 9:15am	United States of America P336 Novel Selective Copper Deposition Method for TGV Filling Seo, Jong Hyun Cuprum Materials Inc., Korea	A*STAR, Singapore P263 Real-Time 3D Reconstruction for Wire Bonding Using Multi-View Projection and EM Polynomial Modelling  Chien, Yu Hsuan ASMPT, Taiwan	Amkor technology, Inc., Korea  P233 A Shock Vibration Calculation Method Considering Viscoplastic Behavior of Packaging Systems  Chen, Honghao  Nanjing University of Posts and	Pte. Ltd., Singapore P374 WireBond Challenges of Copper Clip for Multi-Die Controller MOSFET Package  Chantana Tangcharoensuk  NXP Manufacturing, Thailand	Switzerland P150 112 Gbps SERDES Channel Design with 2.5D Sub-Micron BEOL Interconnect  Ayers, Seann  Applied Materials, United States of America	Germany P178 Aerosol Jet Printing of a Copper Nanoparticle Ink by Controlling the Wetness of Aerosols  Zheng, Cheng Nanyang Technological University,
9:15am – 9:30am		P186 Defect Localization in Material Surfaces Using retinal CSRF kernel and Statistical Peak Profiling Hanmante, Udaykumar Applied Materials	Telecommunications P113 Delamination Effect Investigations Near RDL and UBM in WLCSP Packages Huang, Leo Renesas, Taiwan	P306 Direct Bonding of Aluminum and Polypropylene in High-Reliability Structural Interfaces  Park, Jin Woong  Hanbat National University, Korea	P151 Advanced Bevel Deposition for Enhanced Yield and Cost Efficiency in Wafer-Level Bonding  Xiao, Yun  Lam Research, China	Singapore P162 Heat Release Tape Characterization for Panel Level Packaging Shanmuga Sundaram, Shanthini ST Microelectronics, Singapore
9:30am – 9:45am	P111 Process-induced parasitic surface conduction (PSC) in SOI substrates for 3D-integrated RF front-end applications  Rotaru, Mihai Dragos  Institute of Microelectronics ASTAR, Singapore	P187 Enhancing Wire Bonding Quality Prediction with a Physics- Informed Ensemble Learning Framework  Lu, Hsin-Fang  ASMPT Limited, Taiwan	P368 Feasibility Study of Stacked Sub-THz Band AiP Modules Based on Warpage and Stress Analysis Tsukahara, Makoto SHINKO ELECTRIC INDUSTRIES CO., LTD., Japan	P219 Nanoindentation tests and constitutive study of sintered nanosilver  Yu, Huachen  Nanjing University of Posts and Telecommunications, China	P307 Physics-Informed Graph Convolutional Neural Network for Scalable, and Accurate Thermal Analysis of 2.5D Chiplet-based Systems Sahay, Rahul Singapore University of Technology and Design, Singapore	P175 Reliability Evaluations of Pb- free Solder Joint Formed Using Sn- Ag-Cu solder ball and Sn-Bi-Ag solder paste  Kim, Jahyeon Korea Institute of Industrial Technology (KITECH), Hanyang University, Korea
9:45am -10:15am			30min Coffee Break outsid	le Exhibition Hall (LEO 1-4)		
10:15am -10:45am	Invited Talk 1: Dr Dielacher Bernd (EVG) The Critical Role of Wafer Bonding in Next-Generation Interconnect Scaling	Invited Talk 2: Taichi Suzuki (ULVAC Inc) Polymer Fine Pattern Formation based upon Plasma Etching for High Density RDL Interposer	Invited Talk 3: Dr Zhao Yi (ZSCT) Advanced Packaging EDA's New Paradigm: Collaborative Innovation Revolution for Design-Simulation- Verification in the 2.5D/3D Era	Invited Talk 4: Inohara Masahiro (KIOXIA) Accelerating the Evolution of NAND Flash Memory with Bonding Technologies	Invited Talk 5: Dr Mushuan Chan (SPIL) High Layer RDL Process Technology for Heterogenous Integration Package	Invited Talk 6: Dr Sajay BG (IME) Heterogeneously Integrated WL Processed CPO Engine for Next Gen AI/ML Data Centers
Venue				O 1-4		
10:45am - 11:55am Venue		Tecl	<u> </u>	sion 2 (70 min)   Quiz & Prizes Inclu 60 1-4	ided	
11:55am -1:00pm				PISCES 2 to VIRGO 3		

<b>DAY 3:</b>	December	4, 2025	(con't)
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Interactive Presentation 2 (Poster), Exhibition and Coffee Break outside Exhibition Hall (LEO 1-4)

		DAY 3: December 4, 2025 (con t)				
11:55am -1:00pm			EPTC L	uncheon		
Venue	AQUARIUS 3	AQUARIUS 4	GEMINI 1	GEMINI 2	PISCES 1	PISCES 2
1:00pm -1:45pm	Materials and Processing 3	Thermal Management and Characterization 3	Mechanical Simulation & Characterization 4	Interconnection Technologies 3	Advanced Packaging 4	Quality, Reliability & Failure Analysis 2
Session Chair	Lan Peng, imec	Gamal Refai-Ahmed, AMD	Faxing Che, Micron	Torsten Wipiejewski, Huawei	Albert Lan, AMAT	Tain RaMin, Unimicron
1:00pm – 1:15pm	Sn-3.0Ag-0.5Cu solder joints with Alumina layer deposition  Noh, Eun-Chae  Chungbuk National University, Korea	P191 Magnetohydrodynamic Liquid Cooling Embedded in PCBs for High-power Electronics Feng, Huicheng A*STAR, Singapore	P252 Evaluating Dummy Die Sizes and Compound Adjustments to reduce Wafer Warpage in FOEB-T Packaging.  Zeng, TzuChi Siliconware Precision Industries Co., Ltd., Taiwan	P202 Comparative wear-out study and characterization methods for Pure and Alloyed Copper wires Losacco, Gabriele STMicroelectronics, Italy	P320 Ka-Band Ultra-Short Die-to- Antenna Interconnect Enabled by Embedded Glass Fan-Out Packaging  Jin, Shengxiang  Peking University Shenzhen Graduate School, China	China
1:15pm – 1:30pm	P211 Wettability, Mechanical Properties and IMC of SiC nanoparticle-reinforced Sn-58Bi solders on Cu substrates under multiple reflow cycles  Yao, Wang Harbin Institute of Technology	P270 Numerical Investigation of Embedded Micro-Pin Fin Two-Phase Liquid Cooling for Dual-Chip Stacks in HPC & Al Applications  Patra, Chinmaya Kumar Indian Institute of Technology Kharagpur, India	P369 Characterization and Modelling of Inelastic Behavior of Epoxy Molding Compounds  Tippabhotla, Sasi Kumar  Institute of Microelectronics, A*STAR, Singapore	P378 MDQFN™: Panel-Level QFN for Scalable, Cost-Effective Semiconductor Packaging  Castillo, Chelo Veronica  Deca Technologies, Inc., United States of America	P227 Development of a Wideband Energy Harvesting Circuit Utilizing Terrestrial Digital Broadcast Signals  Tanaka, Hayato  Kyushu University, Japan	P276 A Modified Test Vehicle Incorporating DNP-Induced Strain Gradients for Single-Specimen Fatigue Life Assessment of Solder Joints  Park, Hyeong-Bin Hanyang University, Korea
1:30pm – 1:45pm	P304 Impact of Solder Powder Size on Cleaning Efficiency in Chip Resistor Assemblies for Future Advanced Packaging  Parthasarathy, Ravi  ZESTRON Americas, United States of America	01 /	P220 Nanoindentation Test and Crystal Plasticity Finite Element Model of SAC305 Solder Joint Considering Crystal Orientation Liu, Lu Nanjing University of Posts and Telecommunications, Nanjing, China	P157 Investigation of Cu bonding wire lifetime under accelerated temperature environments  Azuma, Shinya  Nippon Micrometal Corporation, Japan	P146 Optimization of Shielded Capacitive Power Transfer (S-CPT) Systems Using Slotted Electrodes Chen, Hao Kyushu University, Japan	P147 Correlation Between Thermal Cycling Ramp Rates and its Respective Solder Joint Reliability CHAN, Yong Tat STMicroelectronics Pte Ltd, Singapore

1:45pm - 3:15pm

		DAY 3: December 4, 2025 (con't)				
Venue	AQUARIUS 3	AQUARIUS 4	GEMINI 1	GEMINI 2	PISCES 1	PISCES 2
3:15pm -4:00pm	Materials and Processing 4	Thermal Management and Characterization 4	Mechanical Simulation & Characterization 5	Interconnection Technologies 4	Advanced Packaging 5	Assembly and Manufacturing Technology 3
Session Chair	Jie Wu, Henkel	L. Winston Zhang, University of Illinois at Urbana-Champaign	Chai Tai Chong, IME	Po-Hao Tsai, Applied Materials	Chuan Seng Tan, NTU	Cheng Yang, JCET
3:15pm – 3:30pm	P379 Enhancing Yield Performance in Chip-to-Wafer Hybrid Bonding in Advanced Packaging  Xie, Ling  Institute of Microelectronics, A*STAR, Singapore	P371 Direct-Bonded Manifold-Jet- Impingement Cooling for High- Performance Al Chips  Zhang, Yuantong  Xi'an Jiaotong University, China	P352 Statistical Evaluation of Bond Strength Variation in Hybrid Bonding Interfaces Kobayashi, Daiki YOKOHAMA National University, Japan	P299 Fluxless Die to Die Bonding of 10µm Ultra-fine Pitch Microbump Xu, Zheqi Tsinghua University, China	P367 Low Temperature Post Bond Anneal for Hybrid Bonding enabled by Interfacial (IF) Metal Capping – An Assessment of Reliability  Rath, Santosh Kumar  Applied Materials Singapore, Singapore	P196 Growth Behaviour of Intermetallic Compounds in Cu- Sn3.5Ag Solder Joints with Different furnace cooling rate  Gan, Jingjian  NXP Semiconductors, China
3:30pn – 3:45pm	P234 Study on Backside Metallization for the S-SWIFT(TM) Package  Jo, Dambi  Product Development Team, Amkor Technology, Korea	P334 High-Temperature Pressure Mapping of TIM Interfaces for Improved Thermal Simulation Accuracy  U, Srinath  Cisco Systems (India) Private Limited, Bengaluru, India	P349 Real-time Effective Mechanical Property Characterization of Redistribution Layer (RDL) for Chiplet Integration Liu, Jun Institute of High-Performance Computing, A*STAR, Singapore	Advanced Packaging  Cirulis, Imants	P323 Backside Metal Interconnect for High Performance RF Interposer  Lim, Teck Guan  Institute of Microelectronics, A*STAR, Singapore	P158 Hybrid Evaluation of Pure Argon Plasma Treatment for Enhanced Wire Bonding and Manufacturing Efficiency in Microelectronics  Pelingo, Jorell  onsemi Carmona, Philippines
3:45pm – 4:00pm	P189 Study of Coverage Decay Mechanism of Liquid Metal Filler TIM for Advanced Package Application Jhan, Jyun-De Siliconware Precision Industries Co., Ltd., Taiwan	P222 Operando Thermal Analysis of CPU and PCB using a Pixel-level Emissivity Correction Method  Kim, Seongjin  Pohang University of Science and Technology (POSTECH), Korea	P274 Simulation and Validation of	P353 Interfacial Electromigration Behavior and Reliability Evaluation in Cu/Ag Sintered Joints  Kim, Yun-Chan  Korea Institute of Industrial Technology, Korea University, Korea	P256 Surface Activation and Bonding Mechanisms of SiCN and TEOS Dielectrics for Low- Temperature Hybrid Bonding  Chang, Liu  School of Integrated Circuits, Southeast University, China	P363 Comparative Evaluation of FCVA and High-Current Arc Deposited ta-C Films for Hermetic Encapsulation (Mat Paper)  Li, Ying Nanyang Technological University, Singapore

DAY 3: De	ecember 4,	2025	(con't)	)
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		DAY 3: December 4, 2025 (con't)				
Venue			VIRG	O 1-4		
4:00pm - 5:10pm		Tec	hnology Innovation Showcase Sess	sion 3 (70 min)   Quiz & Prizes Inclu	ded	
Venue	AQUARIUS 3	AQUARIUS 4	GEMINI 1	GEMINI 2	PISCES 1	PISCES 2
5:10pm - 5:55pm	Materials and Processing 5	Thermal Management and Characterization 5	Quality, Reliability & Failure Analysis 3	Interconnection Technologies 5	TSV/ Wafer Level Packaging 3	Assembly and Manufacturing Technology 4
Session Chair	Yu Shoji, Toray Industries Inc	Ali Shakouri, Purdue University	Fu Chao, WinTech Nano	Lois Liao, WinTech Nano	Soon Aik Chew, imec	Mandal Rathin, IME
5:10pm – 5:25pm	Via Wafer during Thinning  Xu, Kezhong	P163 Thermal Performance Enhancement of Stacked Packages using Silicon-Based Heat Spreading Die  Lee, Seokjun Daniel  Semiconductor R&D Center, Samsung Electronics, Korea	in 2.5D IC Using Magnetic Field Imaging Cai, Fengkai National University of Singapore,	P261 Microstructure Evaluation of Engineered Cu for Low- Temperature Cu-Cu Hybrid Bonding Tanaka, Fabiana Lie Yokohama National University, Japan	P105 Analysis of Cu and dielectric layer interfacial delamination in chip redistribution layer Chen, Zhiwen Wuhan University, China	P315 Automated In-Line Metrology of Advanced Package Interconnections using a High- Speed 3D X-ray System  Gregorich, Thomas  Zeiss SMT, United States of America
5:25pm – 5:40pm		P381 Solid-State On-Chip Thermal Management Using Micro- Thermoelectric Devices  Kim, Jeong-Hwan  Korea Advanced Institute of Science and Technology, Korea	P200 In-Situ Package Level Relative Humidity Measurement using Wet- Bulb and Dry-Bulb Temperatures  Iyer, Vidya Subramanian  Infineon Technologies Asia Pacific; Nanyang Technological University, Singapore	P179 A Molecular Dynamics Study of Grain Size Effects on Cu-Cu Interfacial Void Reduction in Direct Bonding Interconnect  Park, Junhyeok Ulsan National Institute of Science and Technology, Korea	P126 Mitigation of Cu Nodule Formation in High Open Area Products for Electroplated Cu RDL Applications Lin, SW Lam Research Corporation, Taiwan	P224 Mass Transfer solution for Micro-LEDs based displays  Raphoz, Natacha  CEA - LETI, France
5:40pm 5:55pm	P316 Cost-Effective Wafer Level Micro Bumping Solution for Advanced Packaging  Lip Huei, Yam  Heraeus Materials Singapore Pte Ltd, Singapore	P322 Thermal Sensitivity Analysis of SolC Face-to-Back Stacking Using Foundation Models for Physics  Kabaria, Hardik  Vinci4D.ai Inc, USA	P358 Al-empowered 3D X-ray	P243 In-situ AFM Analysis of Thermal Expansion of Cu Pads with Varied Grain Characteristics  Yang, Gangli  School of Integrated Circuits, Southeast University, China	P265 Characterization on Fan-Out Heterogeneous Integration Packaging for Premium Smartphone Chen, Cheng Chia Siliconware Precision Industries Co., Ltd., Taiwan	P118 Enhancing Electrochemical Migration Resistance of Sintered Silver by Ceria Additives for Die Attachment Applications  Siow, Kim Shyong  Universiti Kebangsaan Malaysia
06:15pm - 08:30pm			Party @ Ola Bead	ch (ticketed event)		

	DAY 4: December 5, 2025					
Venue			VIRGO 1-4			GEMINI 2
8:45am – 10:00am		Technology Innovation	Showcase Session 4 (75 min)	Quiz & Prizes Included		R10 EPS Chapter Officers' Meeting
10:00am - 11:00am		60m	nin Coffee Break outside Exhibition Hall (LEO	1-4)		
Venue	PISCES 1	PISCES 2	PISCES 3	PISCES 4	GEMINI 1	GEMINI 2
Session Chair	Toh Chin-Hock, Lam Research	Rajoo, Ranjan, Globalfoundries	David Gani, STMicroelectronics	ZHANG Xiaowu, IME	Hua Younan, WinTech Nano	Luan Jing-En, STMicroelectronics
11:00am -11:30am	Invited Talk 7: Dr Kathy Yan (TSMC) From Cloud Al to Edge Al: Driving Innovation with Advanced Packaging	Invited Talk 8: Dr Takenori Fujiwara (Toray) Polymer Bonding Technology for Semiconductor Advanced Packaging	Invited Talk 9: Dr Tan Yik Yee (Yole Group) Al Is Accelerating the Shift to Advanced Packaging with FOPLP	Invited Talk 10: Jonathan Abdilla (BESI) Hybrid Bonding and Fluxless TCB: Defining the Sub 10um Interconnect Roadmap for 3D HI	Invited Talk 11: Dr Fu Chao (WinTechNano) Labless Enable Effective FA of Electronics Packages through Scientific Approach	Invited Talk 12: Prof Ali Shakouri (Purdue University) Thermal Characterization and Al Analytics for 3D Heterogeneous Integrated Circuits
11:30am – 12:15pm	Advanced Packaging 6	Materials and Processing 6	Smart Manufacturing and Equipment Technology 2	Interconnection Technologies 6	Quality, Reliability & Failure Analysis 4	Mechanical Simulation & Characterization 6
11:30am -11::45pm	P350 Fabrication of N77/N79 Antenna-plexer: Integration of BAW Filters with Broadband Glass-IPD Diplexer for 5G Applications	P240 Copper Pillar Bump FCBGA Underfill Process Characterization for Automotive Application	P193 Al-driven Pixel-Level Defect Localization using Magnetic Current Images	P143 UV-Assisted Fluxless Thermal-Compression Bonding Under Ambient Conditions	P132 Anomalyspy: A Generative Defect Localization in Semiconductor Packages, with X- ray Microscopy	P321 Degradation Mechanism of Frequency Stability in MEMS Resonant Accelerometers
	Park, Minsoo Korea Electronics Technology Institute, Korea	Koey Poh Meng, Dominic NXP Semiconductors, Malaysia	Aung, Aye Phyu Phyu Institute for Infocomm Research (I2R), A*STAR, Singapore	Kim, You-Gwon Hanyang University, Korea	I Made, Riko Institute of Materials Research and Engineering (IMRE), Singapore	Bie, Xiaorui Institute of CAS, China
44.5	P308 Power and Performance Comparison between FPGA-Optics Integrated 3D SiP and equivalent board level test hardware	P212 Enhanced Reliability of Large BGA Assemblies for Al Server and HPC Application	P236 Research on Intelligent Prediction of 3D-IC Packaging Injection Molding Based on Machine Learning	P244 Characterization of Fine Line Width/Spacing RF Interconnects for Co-Packaged Optics with High I/O Density	P180 Cu/SiCN wafer-to-wafer hybrid bonding interface reliability down to 400 nm pitch	
11:45am -12::00pm	Pamidighantam, V Ramana	Wang, Huaguang	Wu, Jie	Wu, Jia Qi	Zhang Boyao	Albrecht, Jan
	LightSpeed Photonics Private Limited, Singapore	Indium Corporation, United States of America	Nanjing University of Posts and Telecommunications, China	Institute of Microelectronics, A*STAR, Singapore	imec, Belgium	Fraunhofer ENAS; Germany
12:00nm 12:15nm	P361 Process Developments of Chip-to-Wafer assembly with HPC and Photonics Chiplets on large RDL-first interposer	P384 Development and Monitoring of Gold Electroplating Process on 300mm Wafer Level	P359 Cross-Domain Adaptation of Automated 3D X-ray Defect Detection from HBM to Optical Transceivers	P117 Study on Solder Core Ball Using Sn-Bi Plating for Low- Temperature Bonding	P375 Investigations on the Mutual Effects of Electromigration and Thermal Fatigue failures of TSV Interconnects	P329 Advancing Electronic Package Reliability Analysis by Predicting Solder Joint Strain Patterns Using Neural Networks
12:00pm- 12:15pm	Lim, Sharon Pei Siang	Tran, Van Nhat Anh	Wang, Jie	Kim, Hui Joong	Cheng Tian	Meier, Karsten
	Institute of Microelectronics, A*STAR, Singapore	Institute of Microelectronics, A*STAR, Singapore	Institute for Infocomm Research (I2R), A*STAR, Singapore	MKE, Korea	Zhangjiang Lab, China	Technische Universität Dresden, Germany
Venue			VIRG	O 1-4		

Conference Lunch

12:15pm -1:30pm

<b>DAY 4:</b>	<b>December</b>	5, 2025	(con't)	
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12:15pm -1:30pr	12:15	pm -1	1:30pn
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245pm – 3:05pm

## Conference Lunch @ VIRGO 1 to 4

Session Chair Shaw	PISCES 1  dvanced Packaging 7  aw Fong WONG, Intel	PISCES 2  Materials and Processing 7	PISCES 3  Electrical and	PISCES 4	GEMINI 1	GEMINI 2
Session Chair Shaw		Materials and Processing 7	Electrical and			
	aw Fong WONG, Intel		Mechanical Simulations	Smart Manufacturing and Equipment Technology 3	Advanced Optoelectronics and Displays	Mechanical Simulation & Characterization 7
		Kathy Yan, TSMC	Aoyagi Masahiro, AIST	Lee Chee Ping, Lam Research	Sajay BG, IME	Gao Jiaying, Huawei
Passive D us 1:30pm - 1:45pm	emonstration of Integrated Devices in Glass substrate using TGV process  Yi, Sang-Ho ectronics Technology Institute, Korea	P217 Investigation on crack propagation mechanism of Al2O3 direct bond copper substrate  Yu Shan Huang  ASE	P169 Characteristics in the quasi- millimeter wave band of planar transmission lines formed on flexible substrates  Kimigawa, Ryoma Kyushu University	P348 Inferring Wire Length and Depth from Magnetic Field Images via Deep- Spatial Physics Informed Model  Jayavelu, Senthilnath  Institute for Infocomm Research (I2R), A*STAR, Singapore	P267 Assembly of optical micro-ring resonator-based ultrasound sensor for photoacoustic imaging Lepukhov, Evgenii Tampere university, Finland	P139 Key Insights into Design for Reliability of 3D NAND Packages in Solid-State Drive  Pan, Ling  Micron Semiconductor Asia Pte Ltd, Singapore
		•	P289 Development of PDK Library for Accurate Modelling of 2.5D Interconnect Structures in Heterogeneous Integration Mani, Raju Institute of Microelectronics, A*STAR, Singapore	P213 Device-to-Package Electrothermal Performance Prediction of Power	P104 High Coupling Efficiency Adhesive for Photonic Packaging Lim, See Chian Garian DELO Industrial Adhesives	P373 A novel wafer warpage numerical model considering further shrinkage of epoxy molding compound  Ji, Lin  Institute of Microelectronics, A*STAR, Singapore
Coatings Mechanica Pac 2:00pm – 2:15pm	igh-Performance Graphene s for Superior Thermal and ical Properties in Electronic ackaging Enclosures ndararajan, Muralidharan s Storage Sdh Bhd, Malaysia	P232 A novel mitigate solder short circuit in double-sided copper- exposed power modules Yu Hsien Chien ASE		P209 Thermal- and Wirelength-Aware Chiplet Placement in 2.5D Systems Through Multi-Agent Reinforcement Learning Hou, Yubo Institute for Infocomm Research (I²R), A*STAR, Singapore	P253 2.5D PIC Photonic Interposer Engine for Next Generation Photonic Link CPO of High-Performance Computing and Data Communications Chi, Ting Ta Institute of Microelectronics, A*STAR, Singapore	P127 Development of Warpage Predictive Models using Physics-Driven Simulation  Yu, Wei  Micron Semiconductor Asia Operations, Singapore
2:15pm - 2:30pm Davi	Invited Talk 13 vid Gani (STMicro) nges and Advantages in nel Level Packaging		Invited Talk 15: Dr Min Woo Rhee (Samsung) Understanding of Hybrid Bonding Mechanism by Utilizing Molecular Dynamics Approach	P264 Generative Al-Powered Defect Detection for 3D X-ray Microscopy Scans of High Bandwith Memory Bumps Chang, Richard	P206 An Integrated Computational	P239 Thermal and mechanical properties optimization of TGV interposer for 2.5D integrated transceiver  Li, Chunlei  Xiamen University; Sanming University, China
2:30pm - 2:45pm						

20min Coffee Break outside Exhibition Hall (LEO 1-4)

	DAY 4: December 5, 2025 (con't)
2:45pm – 3:05pm	20min Coffee Break outside Exhibition Hall (LEO 1-4)
Venue	VIRGO 1,2 and 3 (combined rooms)
3:05pm - 5:05pm	Heterogeneous Integration Roadmap (HIR) Workshop Theme: Interconnects - Design and Manufacturing of Complex HI Structures  Opening: Kitty Pearsall  Design for Manufacturability of > 1 kW: Gamal Refai Ahmed (AMD) Photonics Design: Amr S Helmy (University of Toronto)  HBI Manufacturability HBI: Loke Yuan Wong (Applied Materials) TCB Manufacturability: Li Ming (ASMPT)  CPO Manufacturability: Surya Bhattacharya (IME, A*STAR)  Panel Discussion  "Why HBI/CPO HVM Adaption is in Slower Pace Despite all the Buzz?" Moderator: Wong Shaw Fong (Intel)
5:10pm - 5:30pm	Closing Ceremony and Lucky Draw @ VIGRO 1, 2 and 3 (combined rooms)